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PATENT
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Supplemental
IDS
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R Shrotriya

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	Lynn David Bollinger, et al.
Serial No. 09/693,117	Filing Date: October 20, 2000
Title of Application:	Method for Rapid Thermal Processing of Substrates
Group Art Unit:	2812

Assistant Commissioner for Patents
Washington, DC 20231

Supplemental Information Disclosure Statement by Applicants

Dear Sir:

As a means of complying with duty of disclosure set forth in 37 CFR §1.56, Applicants list the following references which have recently come to our attention as the result of the international search report (copy enclosed).

U.S. Patent Documents				
Exam. Initials	Class/ Subclass.	Document No.	Date	Name
MW	425/77	5,122,043	06/16/92	Matthews
MW	437/248	5,336,641	08/09/94	Fair et al.
MW	134/1.1	5,843,239	12/01/98	Shrotriya
MW	438,398	5,913,127	06/15/99	Dennison et al.

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Commissioner of Patents and Trademarks; Washington, DC 20231.

July 31, 2001

Caroline Gahagan